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Application Number	10/734,699
Filing Date	Dec. 12, 2003
First Named Inventor	Robert Todd Belt
Group Art Unit	
Examiner Name	
Attorney Docket Number	RTB001US

(use as many sheets as necessary)

Sheet	1	of	3
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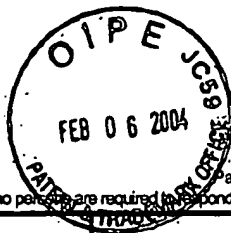
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PTO/SB/08A (10-96)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet **2** of **3**

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OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials ²	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
[Signature]	8	Bifano, Thomas G. et al., "Continuous-membrane Surface-micromachined Silicon Deformable Mirror" <i>Optical Engineering</i> 36:5 (May 1997) p. 1354-1360.	
	9	Ealey, Mark A. et al., "Continuous Facsheet Low Voltage Deformable Mirrors" <i>Optical Engineering</i> 29:10 (October 1990) p. 1191.-1198.	
	10	Hulburd, Bill et al., "Segmented Mirrors for Atmospheric Compensation" <i>Optical Engineering</i> 29:10 (October 1990) p. 1186-1190.	
	11	Lim, C.W. et al., "Three-dimensional Electromechanical Responses of a Parallel Piezoelectric Bimorph" <i>International Journal of Solids and Structures</i> , Vol. 38 (2001) p. 2833-2849.	
	12	Mali, Raji Krishnamoorthy et al., "Development of Microelectromechanical Deformable Mirrors For Phase Modulation of Light" <i>Optical Engineering</i> 36:2 (February 1997) p. 542-548.	
	13	Morris, Christopher J. et al., "Optimization of a Circular Piezoelectric Bimorph for a Micropump Driver" <i>Journal of Micromechanical Microengineering</i> , Vol. 10, (2000) p. 459-465.	
	14	Hoffmann et al., "Fabrication and Characterization of a PZT Thin Film Actuator for a Micro Electromechanical Switch Application" <i>Materials Research Society Symposium Proceedings</i> Vol. 688, C5.9 (2002) p. 145-152.	
	15	Roggemann, Michael C. et al., "Use of Micro-electro-mechanical Deformable Mirrors to Control Aberrations in Optical Systems: Theoretical and Experimental Results" <i>Optical Engineering</i> 36:5 (May 1997) p. 1326-1338.	
	16	Shwartz, Josef et al., "Tactical High Energy Laser" SPIE Proceedings on Laser and Beam Control Technologies" Vol. 4632 (January 21, 2002).	
	[Signature]	17	Vdovin, Gleb et al., "Technology and Applications of Micromachined Silicon Adaptive Mirrors" <i>Optical Engineering</i> 36:5 (May 1997) p. 1382-1390.
18		Winsor, R. et al., "Finite Element Analysis of Low Cost Membrane Deformable Mirrors for High Order Adaptive Optics" Proceedings of SPIE - High Resolution Wavefront Control: Methods, Devices and Applications, Denver, Colorado (July 19-20, 1999) p. 2-11.	

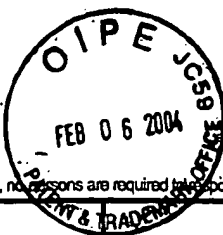
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	19	Winsor, R. et al., "Low Cost Membrane Type Deformable Mirror With High Density Actuator Spacing" Proceedings of SPIE - Adaptive Optical Systems and Technology, Munich, Germany (March 29-31, 2000) p. 563-572.	
	20	Yang, Eui-Hyeok (EH) et al., "Design and Fabrication of Electrostatic Actuators With Corrugated Membranes for MEMS Deformable Mirror in Space" Proceedings of SPIE - Imaging Technology and Telescopes, San Diego, California, Vol. 4091 (July 30-31, 2000) p. 83-89.	

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